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Ophir Optronics Acquires Photon Inc.; Adds Innovative Scanning-Slit Technology to Beam Profiling Product Line

May 17, 2010 – Jerusalem, Israel – Ophir Optronics, the global leader in precision laser measurement, today announced the acquisition of **Photon Inc.** (San Jose, CA), a developer of precision laser beam profiling optical test equipment. The acquisition adds Photon's experience and products to the Ophir-Spiricon group and creates a diverse, powerful, and largest supplier of laser measurement equipment for industrial, medical, military and scientific/research applications.

Ophir-Spiricon now provides the most comprehensive line of beam profiling equipment and software. Photon Inc.'s extensive experience with laser and fiber beam characterization in the photonics industry supports solving complex optical problems and provides semi-customized measurement system designs. Of special interest in the acquisition was Photon's scanning-slit technology. Their scanning-slit well known NanoScan Profilers provide high accuracy and precision for the measurement of CW and KHz pulsed laser beams across the spectrum range from UV to far infrared. The scanning-slit technology offers the highest ease-of-use profiling because it can measure most high power beams without the need for complicated attenuation schemes.

"I am delighted that we have been able to bring together two highly innovative businesses," stated Moty Gelbman, General Manager of the Laser Measurement Group at Ophir. "Photon Inc. and its products are a perfect complement to Ophir-Spiricon's beam profiling business. Photon's people and products are well respected, as are our own. And Photon's scanning-slit technology combines accuracy and ease of use for a wide range of applications, including real time operations."

About Photon Inc.

Established in 1984, Photon Inc. is a innovative manufacturer of laser beam profiling systems. The company provides a range of accurate and easy-to-use instruments for aligning and building laser optical systems, collimating lasers, and characterizing fiber optic beams, lasers, and other light sources. They were the first to provide real-time focused beam size measurements for laser beams with their BeamScan family of profilers. Today, their low noise NanoScan scanning-slit technology is capable of measuring the waist of a collimated mm diameter laser beam to within a centimeter. NanoScans are frequently used to directly measure tightly focused spots. Photon systems are used across a diverse range of applications, including automation, laser and laser system manufacturing, and design/test. Photon also offers a patented line of high speed Goniometric Radiometers to spatially characterize LD's LED's and optical fibers used in telecommunications as well as laser sources.

About Ophir-Spiricon

Established in 1978, Spiricon merged with Ophir Optronics in 2006 and became Ophir-Spiricon, part of the Laser Measurement Group in 2006. The Laser Measurement Group provides a complete line of instrumentation including power and energy meters, beam profilers, and spectrum analyzers. Dedicated to continuous innovation in laser measurement, the company holds a number of patents, including **Ultracal™**, the baseline correction algorithm that helped establish the ISO 11146-3 standard for beam measurement accuracy. The company's modular, customizable solutions serve manufacturing, medical, military, and research industries throughout the world. For more information, visit <http://www.ophiropt.com>.

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